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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE	
REPLY TO OFFICE ACTION DATED 01/16/04	
Atty. Docket No. DUPONT1120-1	
Applicant Michael J. Penberth	
Application Number 09/262,778	Date Filed 03/04/99
Title Electron Beam Blanking Method and System for Electron Beam Lithographic Processing	
Group Art Unit 2625	Examiner Chawan, Sheela C.
Confirmation Number: 9973	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

<p align="center"><u>Certificate of Mailing Under 37 C.F.R. §1.8</u></p> <p>I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22312-1450 on <u>APRIL 6, 2004</u>.</p> <p align="center"> Signature</p> <p align="center"><u>LAURA M. MCGUIRE</u> Printed Name</p>

In response to the Official Action mailed January 16, 2004, Applicant respectfully requests the Examiner reconsider the rejections of the Claims in view of the this reply.

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